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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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Title of Invention : METHOD FOR MEASURING A SURFACE PLASMON  
RESONANCE AND NOBLE METAL COMPOUND  
USED FOR THE SAME

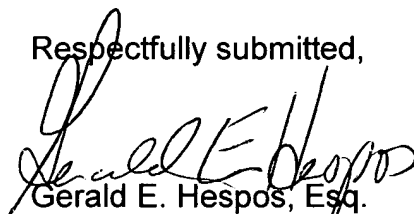
MS PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Sir:

This Information Disclosure Statement includes a copy of Form PTO-1449 that identifies seven Japanese references and one WIPO publication. Copies of the references are attached as well. These references were identified as being relevant in the International Search Report, a copy of which is submitted concurrently with this Information Disclosure Statement. The Examiner is requested to consider these references during the examination and to make the references of record.

Respectfully submitted,



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